## IE UNITED STATES PATENT AND TRADEMARK OFFICE

icant:

Fang

Attorney Docket: 01 P 14755 US

Filed:

August 28, 2001

Examiner:

Lee, Hsien Ming

Serial No.:

09/941,963

Art Unit:

2823

Title:

Method of Cleaning an Inter-Level Dielectric Interconnect

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

MAILING CERTIFICATE

I hereby certify that this correspondence and all attached documentation is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, Va. 22313-1450.

Julié Russ

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

Applicant wishes to bring to the attention of the U.S. Patent and Trademark Office the information noted on the enclosed Form PTO/SB/08A, which may be considered material to the examination of the above-identified application.

This Information Disclosure Statement is submitted under 37 C.F.R. §1.97(c) together with a \$180.00 fee under 37 C.F.R. §1.17(p) after the C.F.R. §1.97(b) time period, but before final action or notice of allowance, whichever occurs first.

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Respectfully submitted,

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PTO/SB/08A (05-03)
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT  (use as many sheets as necessary)					Complete if Known			
					Application Number	09/941,963		
				RE	Filing Date	August 28, 2001		
				IT	First Named Inventor	Fang		
					Art Unit	2823		
					Examiner Name	Lee, Hsien Ming		
Sheet	1	of		1	Attorney Docket Number	01 P 14755 US		

U.S. PATENT DOCUMENTS							
Examiner Initials*	Cite No.1	Document Number  Number - Kind Code <sup>2 (if known)</sup>	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
	Α	US-4,357,203	11-02-1982	Zelez			
	В	US-5,849,367	12-15-1998	Dixit, et al.			
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, FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No.1	Foreign Patent Document  Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
	С	JP 02246246	10-02-1990	Fujitsu Ltd.		
	D	JP 2001217400	08-10-2001	Agilent Technologies, Inc.		
	E	JP 2001118846	10-18-1999	Sony Corp.		
	F	WO 01/29879 A2	04-26-2001	Mattson Technology, Inc., et al.		
	G	EP 1081751 A2	03-07-2001	Applied Materials, Inc.		
	Н	WO 00/34997	06-15-2000	Applied Materials, Inc.		-

Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	I	ZHAO, B., et al., "Integration of Low Dielectric Constant Materials in Advanced Aluminum and Copper Interconnects," Mat. Res. Soc. Symp. Proc., Vol. 564, 1999 Materials Research Society, pp. 485-497.	

Examiner	•	Date	
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 'Applicant's unique citation designation number (optional). <sup>2</sup>See Kinds Codes of USPTO Patent Documents at <a href="https://www.uspto.gov">www.uspto.gov</a> or MPEP 901.04. <sup>3</sup>Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language

Translation is attached.
This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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